

AMERICAN ACADEMY OF IMPLANT DENTISTRY FOUNDATION
Isaih Lew Memorial Research Award

Background

This award perpetuates Dr. Isaih Lew's spirit and enthusiasm for implant dentistry. Dr. Lew was a pioneer in all phases of implants, beginning in 1948 and continuing until his death in 1982. He developed unilateral implants and the Lew screw, which was the first root-form implant.

A founding member of the Academy, Dr. Lew served as president in 1956 and was editor of the *Journal of Oral Implantology* for many years. He published and lectured widely in the United States and throughout the world. In addition to maintaining a dental practice in New York City, he taught at several dental schools in the Northeast.

Dr. Lew was committed to "the where, why and how" of implantology and left the legacy of being a learned practitioner.

Objective

This award honors an individual who has contributed significantly to research in implant dentistry and who has demonstrated singular leadership and/or responsibility in research that advances the science of implant dentistry.

Criteria

Selection of the recipient of the award will be based upon the following criteria:

- The scope of the nominee's research and its impact on clinical implant dentistry.
- High level of intellectual curiosity.
- Publication in refereed journals.
- Recipient must be able to attend the AAID Annual Conference.

Nomination Procedure

Letters of nomination describing the nominee's accomplishments in the context of the objectives of this award and a curriculum vita with a list of publications should be submitted. The letter(s) should be explicit in describing the impact of the nominee's research on implant dentistry.

Deadline

Nominations must be received in the AAIDF office by July 15. Please email nominations to Foundation@aaid.com with the subject Isaih Lew Memorial Research Award.

Award

The award is selected by the AAID Foundation Board of Directors and is presented during the Annual Meeting of the American Academy of Implant Dentistry.